



TECHNICAL DATA SHEET

LAMINAR[®] E9200 DRY FILM PHOTOPOLYMER

DESCRIPTION

LAMINAR[®] E9200 DRY FILM PHOTOPOLYMER is a negative working aqueous resist designed for print & etch, tent & etch and pattern plate applications in the production of printed circuit boards (PCB'S).

PHYSICAL CHARACTERISTICS

Film type Characteristic	LAMINAR [®] E9213	LAMINAR [®] E9215	LAMINAR [®] E9220	LAMINAR [®] E9225	LAMINAR [®] E9230
Thickness (µm)	33 ± 2	40 ± 2	50 ± 2	62 ± 2	75 ± 2
Colour unexposed	Green	Green	Green	Green	Green
Colour exposed	Blue	Blue	Blue	Blue	Blue
Recommended uses	Print & Etch	Print & Etch Tent & Etch Plating	Print & Etch Tent & Etch Plating	Print & Etch Tent & Etch Plating	Print & Etch Tent & Etch Plating

PRODUCT CHARACTERISTICS

- ✚ High resolution capability.
- ✚ Good post exposure colour contrast for ease of inspection.
- ✚ Good tenting properties.
- ✚ Good plating characteristics.
- ✚ Alkaline and acidic etch resistant.
- ✚ Broad process latitude in each processing step

PROCESSING

SURFACE PREPARATION

The optimum performance of LAMINAR[®] E9200 depends on the condition and cleanliness of the copper surface immediately prior to lamination.

LAMINAR[®] E9200 can be used on the following surface types:

- ✚ Wet brushed base copper.
- ✚ Chemically cleaned base copper.
- ✚ Brush pumiced / aluminium oxide (Al₂O₃) base copper.
- ✚ Electroless copper.
- ✚ Electroplated copper.
- ✚ Direct metallisation surfaces.

For maximum dry film adhesion the surface to be coated must be clean, dry, and free of contaminants such as chromate conversion coatings (Inner layers), residual water and acid stains. Other contaminants include oil in air-lines, nylon brush smear, fingerprints and airborne contaminants generated by the environment in the wet chemistry area.

Panels that have been prepared for lamination should go directly to the laminating area to avoid the risk of contamination.

LAMINATION

LAMINAR[®] E9200 series resists can be applied with all types of commercially available laminators. The automatic cut sheet laminator is preferred as it eliminates trim waste and provides an exposed copper border around all four sides of the substrate.

Lamination of **LAMINAR[®] E9200** must be performed in an environment that is free from dust and dirt. The use of a panel cleaner in the line sequence immediately prior to lamination is strongly recommended to help ensure clean panels during application of the dry film photo resist. The condition and maintenance of the lamination equipment is very important to help achieve consistently high yields.

The dry film photo resist immediately after lamination is soft and susceptible to handling damage. To this end, substrates should be racked to prevent pressure marking of the photo resist. This will also allow substrates to cool to room temperature prior to exposure. Substrates should not be stacked on top of each other, as this can cause trapped particles to imprint the resist from one board to the next. Stacking also tends to trap heat and can adversely impact resist performance during exposure and / or development.

LAMINAR[®] E9200 has been designed with good flow and fill characteristics. Although specific lamination parameters should be established based on the product type and complexity of the substrate being processed, the table below provides general guidelines for use:

Lamination guidelines:

Manual Hot Roll Laminator:	
Roll temperature	100 - 130°C (212 - 266°F)
Lamination speed	1.0 - 3.0m/min (3.3 - 9.8ft/min)
Lamination pressure	2.5 - 3.0Bar
Automatic Cut Sheet Laminator:	
Roll temperature	100 - 130°C (212 - 266°F)
Lamination speed	1.0 - 3.0m/min (3.3 - 9.8ft/min)
Lamination pressure	2.0 - 5.0Bar* Equipment dependant
Tacking time	1.0 - 4.0seconds
Tack bar temperature	60 - 80°C (140 - 176°F)
Substrate entry temperature	21 - 50°C (070 - 122°F)
Substrate exit temperature (I/L)	50 - 70°C (122 - 158°F [Core thickness dependant])
Substrate exit temperature (O/L)	40 - 60°C (104 - 140°F)

EXPOSURE

LAMINAR[®] E9200 can be processed on conventional light sources as used in the Printed Circuit Board industry. Sub 40µm resolution is possible with **LAMINAR[®] E9200** in controlled and optimised production environments.

Film type	LAMINAR[®] E9213	LAMINAR[®] E9215	LAMINAR[®] E9220	LAMINAR[®] E9225	LAMINAR[®] E9230
Energy (mj/cm ²)	55 - 95	60 - 100	70 - 110	74 - 115	78 - 120
St21 Resist step	08 - 10	08 - 10	08 - 10	08 - 10	08 - 10
St21 Copper step	09 - 11	09 - 11	09 - 11	09 - 11	09 - 11
St41 Resist step	22 - 28	22 - 28	22 - 28	22 - 28	22 - 28
St41 Copper step	23 - 29	23 - 29	23 - 29	23 - 29	23 - 29

Energy values quoted above were taken through the photo-tool with an ORC UV-350 radiometer.

Photosensitivity and photo-tool reproduction data for **LAMINAR[®] E9200** processed on an ORC EXM1201F exposure unit:

Photosensitivity

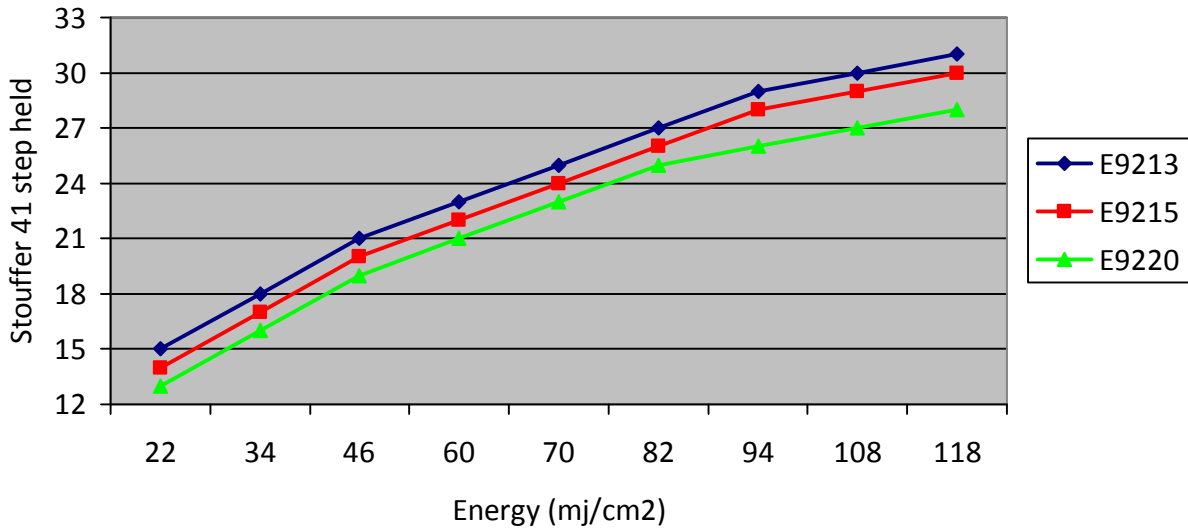
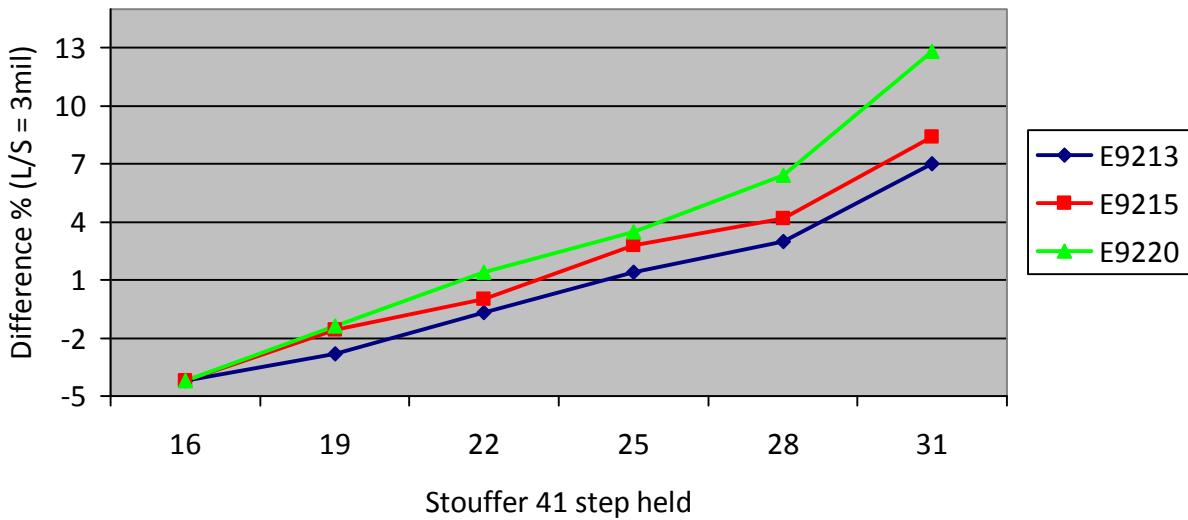


Photo-tool Reproduction



DEVELOPMENT

LAMINAR[®] E9200 dry film photo resist develops in a totally aqueous solution of sodium or potassium carbonate. Water miscible solvents will be detrimental to the photo-resist and should not be used in the developing process.

Characteristic	Optimum	Range
Sodium carbonate	0.85%	0.70 - 1.00%
Potassium carbonate	1.00%	0.80 - 1.20%
Temperature	28 - 30°C (82 - 86°F)	25 - 35°C (77 - 95°F)
Breakpoint	55%	50 - 65%
Pressure	1.50 - 1.70Bar	1.50 - 2.00Bar
Rinse water type	Hard water 150 - 300ppm CaCO ₃ equivalent	
Rinse temperature	20 - 25°C (68 - 77°F)	15 - 30°C (59 - 86°F)
Drying	Hot air blow off with complete drying	
Developing time (1)	E9213	38 - 46 seconds at 28°C (82°F)
Developing time (2)	E9215	50 - 62 seconds at 28°C (82°F)
Developing time (3)	E9220	60 - 70 seconds at 28°C (82°F)
Developing time (4)	E9225	72 - 86 seconds at 28°C (82°F)
Developing time (5)	E9230	86 - 104 seconds at 28°C (82°F)

The operating temperature of the working solution is extremely important to the development of the resist. Exceeding the recommended temperature range can cause attack of the resist sidewall or foot, resulting in resist lifting or ragged tracks. Operating at a lower temperature can result in attack of the resist due to excessive dwell time in the developing chamber.

The breakpoint should be maintained within the recommended range of the developing chamber length. The breakpoint should be established by marking a clean copper panel with lines using a water soluble marker pen immediately prior to lamination of the dry film photo resist. The breakpoint is defined as the point when the developing solution breaks through the interface between the resist and the copper removing the pen lines from the board surface.

Test panels that simulate the manufacturing process should be processed prior to production to set the proper parameters for the process.

Antifoam:

LAMINAR[®] E9200 may require the use of a defoamer. This will depend on several factors including water quality, developer chemistry quality, dry film photo resist loading and equipment design.

If antifoam additions are required, AF80 and AF2750 have been tested and shown to be acceptable and compatible with **LAMINAR[®] E9200**. Other anti-foams may be acceptable but these should be fully evaluated prior to use.

Anti-foam should be added according to the antifoam data sheet. Antifoam should be continuously added to the developer sump by means of a feed pump.

Note:

Do not use antifoam products containing water miscible solvents as they will attack the dry film photo resist. Some petroleum based antifoams are also known to attack dry film photo resist and should be avoided.

ETCHING

LAMINAR[®] E9200 is designed for acid and alkaline etching. The product will withstand acid etchants, such as Cupric and Ferric chloride with free HCL normality <3.0N and alkaline etching solutions between pH 7.8 to 9.0.

PLATING

LAMINAR[®] E9200 has excellent chemical resistance and performs well in acidic electroplating baths including acid copper, tin, tin-lead, nickel and gold.

Recommended pre-plate cleaning process sequence:

Process sequence	Temperature / Time etc	
Acid cleaner	30 - 55°C (86 - 131°F)	2 - 3minutes
Spray rinse	1 - 2minutes	
Rinse counter flow (optional)	1 - 2minutes	
Micro-etch	0.38µm (15µ") Cu removed	As required
Spray rinse	1 - 2minutes	
Sulphuric acid	5 - 10 vol%	1 - 2minutes
Spray rinse (optional)	1 - 2minutes	

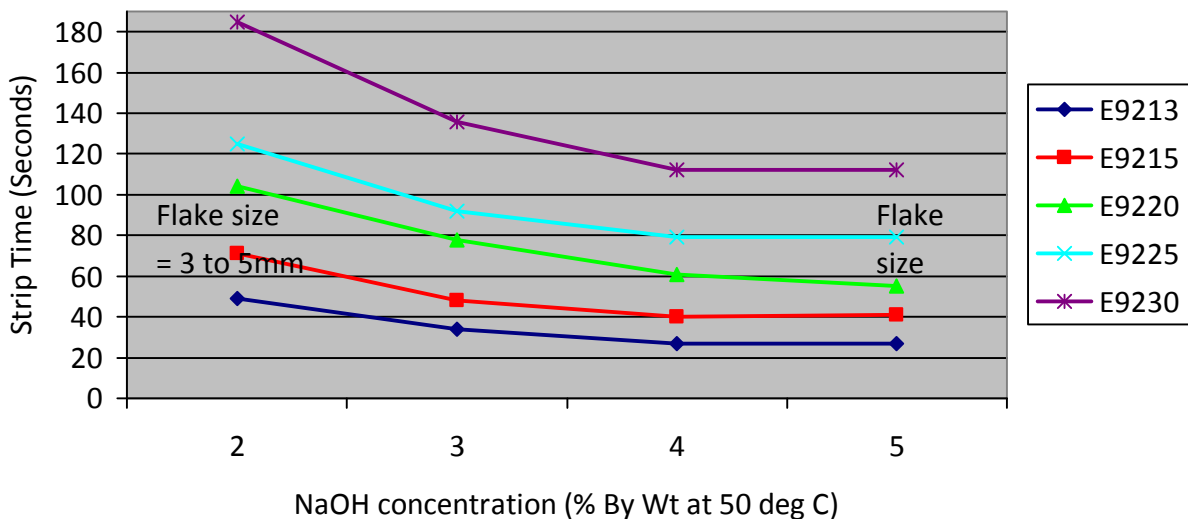
STRIPPING

LAMINAR[®] E9200 dry film photo resist can be stripped in conventional immersion or conveyorised equipment using caustic and proprietary chemistries. Increasing the stripper concentration and temperature decreases the stripping time but causes an increase in the size of the stripped flakes. Continuous removal of stripped resist is recommended to avoid spray nozzle and filter plugging, and to increase bath life.

Stripping times of flood exposed boards processed with LAMINAR[®] E9200 in tank stripping mode are shown in the table below. Actual stripping times will depend upon equipment configuration, exposure level, hold time prior to stripping etc and hence these figures should be used only as a guide.

Film type	LAMINAR [®] E9213	LAMINAR [®] E9215	LAMINAR [®] E9220	LAMINAR [®] E9225	LAMINAR [®] E9230
Solution	NaOH	NaOH	NaOH	NaOH	NaOH
Concentration	2 - 5%	2 - 5%	2 - 5%	2 - 5%	2 - 5%
Temperature	50°C	50°C	50°C	50°C	50°C
Time	28 - 50 seconds	40 - 70 seconds	55 - 105 seconds	80 - 125 seconds	110 - 185 seconds

Stripping Time & Flake Size



As with developing, LAMINAR[®] E9200 may require a defoamer for stripping. AF80 is recommended for this application and should be added according to the antifoam data sheet recommendations.

STORAGE

LAMINAR[®] E9200 should be stored in a limited access area between 5 and 20°C (41 and 68°F) and 50 ± 10% relative humidity. For optimum performance, store in an area not exceeding 15°C (60°F). **LAMINAR[®] E9200** is sensitive to sunlight and indirect white light. Gold or yellow safelights are required in the immediate work area.

SAFETY AND HANDLING

BEFORE USING LAMINAR[®] E9200, PLEASE REFER TO THE CURRENT MATERIAL SAFETY DATA SHEET (MSDS) FOR DETAILED SAFETY, HANDLING AND STORAGE INFORMATION.

LAMINAR[®] E9200 should be applied in a well ventilated area. Commercial lamination equipment may cause vapours to be generated from the dry film, and these should be removed by conventional exhaust techniques. It is the customer's responsibility to ensure that disposal of this and other ancillary products comply with local, state and national federal guidelines.

Wash thoroughly after handling any dry film photo resist. Contact of the unexposed resist with the skin may cause irritation and should be avoided. Sensitisation may occur in some individuals. If contact occurs, wash thoroughly with soap and water. If irritation occurs and persists consult a physician. Avoid reuse of or contact with the dry film release sheets and cover sheets as they may retain small amounts of unpolymerised photo resist components. During cleaning, developing, stripping and etching operations follow the safety precautions pertaining to the particular solution(s) being used.

Based on our experience, we believe that the above information is accurate, but we offer no guarantee as to the use or application of our products or of this information. We warrant our products to be free from defects in material and workmanship; but because their use is beyond our control, we accept no responsibility or liability for damages, whether direct, indirect or consequential, resulting from failure in performance. In cases where our products are found to be defective in material and workmanship, our liability is limited to the purchase price of the products found to be defective. THIS WARRANTY IS TO THE EXCLUSION OF ALL OTHER WARRANTIES OR GUARANTEES, EXPRESS OR IMPLIED, AS TO MERCHANTABILITY, FITNESS FOR ANY PARTICULAR PURPOSE, DESCRIPTION, PRODUCTIVENESS OR ANY OTHER MATTER. None of the above information may be construed as a recommendation that our products be used in violation of any patent rights. We accept your orders at our shipping points only on the basis of the above understanding which our employees have no authority to vary.

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